

# Laboratory:Multi-Functional Materials Science 2000-2004

著者	Institute for Materials Research, Tohoku University
journal or publication title	List of Publications 2000-2004
URL	<a href="http://hdl.handle.net/10097/56484">http://hdl.handle.net/10097/56484</a>

Tang, XF; Chen, LD; Takashi, G; Toshio, H; Yuan, RZ

*Solid state reaction synthesis of skutterudite compounds  $FexCo4-xSb12$  and thermoelectric properties*

Acta Phys. Sin.

49 (2000) 1120 – 1123

00-IMR0484

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Solid state reaction synthesis and structure of filled skutterudite compounds  $BayFexCo4-xSb12$*

Acta Phys. Sin.

49 (2000) 2196 – 2200

00-IMR0485

Tang, XF; Chen, LD; Goto, T; Toshio, H; Yuan, RZ

*Effect of Fe content on the crystal structure and the thermoelectric transport properties of  $CeyFexCo4-xSb12$*

Acta Phys. Sin.

49 (2000) 2437 – 2442

00-IMR0486

Tang, XF; Chen, LD; Takashi, G; Toshio, H; Yuan, RZ

*Effect of Ce filling fraction on thermoelectric transport properties of p-type  $CeyFe1.5Co2.5Sb12$*

Acta Phys. Sin.

49 (2000) 2460 – 2465

00-IMR0487

Chen, L; Tang, X; Goto, T; Hirai, T

*Synthesis of filled skutterudite compounds:  $BayFexCo4-xSb12$*

J. Mater. Res.

15 (2000) 2276 – 2279

00-IMR0488

Orihashi, M; Noda, Y; Chen, LD; Goto, T; Hirai, T

*Effect of tin content on thermoelectric properties of p-type lead tin telluride*

J. Phys. Chem. Solids

61 (2000) 919 – 923

00-IMR0489

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Solid state reaction synthesis of filled skutterudite compounds  $(Ce \text{ or } Y)(y)FexCo4-xSb12$  and the effect of filling atoms Ce or Y on lattice thermal conductivity*

Sci. China Ser. B-Chem.

43 (2000) 306 – 312

00-IMR0490

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Thermoelectric properties of p-type BayFexCo<sub>4-x</sub>Sb12*

Acta Phys. Sin.

50 (2001) 1560 – 1566

01-IMR0564

Wang, XR; Masumoto, H; Someno, Y; Chen, LD; Hirai, TS

*Stepwise graded refractive-index profiles for design of a narrow-bandpass filter*

Appl. Optics

40 (2001) 3746 – 3752

01-IMR0565

Shen, Q; Chen, L; Goto, T; Hirai, T; Yang, J; Meisner, GP; Uher, C

*Effects of partial substitution of Ni by Pd on the thermoelectric properties of ZrNiSn-based half-Heusler compounds*

Appl. Phys. Lett.

79 (2001) 4165 – 4167

01-IMR0566

Chen, LD; Kawahara, T; Tang, XF; Goto, T; Hirai, T; Dyck, JS; Chen, W; Uher, C

*Anomalous barium filling fraction and n-type thermoelectric performance of BayCo<sub>4</sub>Sb12*

J. Appl. Phys.

90 (2001) 1864 – 1868

01-IMR0567

Tang, XF; Zhang, LM; Yuan, RZ; Chen, LD; Goto, T; Hirai, T; Dyck, JS; Chen, W; Uher, C

*High-temperature thermoelectric properties of n-type BayNi<sub>x</sub>Co<sub>4-x</sub>Sb12*

J. Mater. Res.

16 (2001) 3343 – 3346

01-IMR0568

Tang, XF; Chen, LD; Goto, T; Hirai, T

*Effects of Ce filling fraction and Fe content on the thermoelectric properties of Co-rich CeyFexCo<sub>4-x</sub>Sb12*

J. Mater. Res.

16 (2001) 837 – 843

01-IMR0569

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Synthesis and thermoelectric properties of filled skutterudite compounds CeyFexCo<sub>4-x</sub>Sb12 by solid state reaction*

J. Mater. Sci.

36 (2001) 5435 – 5439

01-IMR0570

Onodera, A; Matsumoto, K; Hirai, T; Goto, T; Motoyama, M; Yamada, K; Kohzuki, H

*Synthesis of dense forms of B-C-N system using chemical-vapor-deposition/high-pressure process*

J. Mater. Sci.

36 (2001) 679 – 684

01-IMR0145

Shen, Q; Zhang, LM; Chen, LD; Goto, T; Hirai, T

*Thermoelectric properties of ZrNiSn-based half-Heusler compounds by solid state reaction method*

J. Mater. Sci. Lett.

20 (2001) 2197 – 2199

01-IMR0571

Yonenaga, I; Akashi, T; Goto, T

*Thermal and electrical properties of Czochralski grown GeSi single crystals*

J. Phys. Chem. Solids

62 (2001) 1313 – 1317

01-IMR0157

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Akashi, T; Yonenaga, I; Gunjishima, I; Goto, T

*High temperature transport property of B- and P-doped GeSi single crystals prepared by a Czochralski method*

Mater. Trans.

42 (2001) 1024 – 1027

01-IMR0162

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Gunjishima, I; Akashi, T; Goto, T

*Thermoelectric properties of single crystalline B4C prepared by a floating zone method*

Mater. Trans.

42 (2001) 1445 – 1450

01-IMR0573

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Akashi, T; Morita, K; Hirai, T; Yamane, H; Goto, T

*Phase relationship in a BaO-Bi2O3-TiO2 system and electrical properties of BaTiO3 with addition of Bi4Ti3O12*

Mater. Trans.

42 (2001) 1823 – 1826

01-IMR0574

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Tu, R; Goto, T; Chen, LD; Hirai, T; Zhang, LM

*Corrosion behavior of glass coated Hastelloy-XR in boiling sulfuric acid*

Mater. Trans.

42 (2001) 2093 – 2097

01-IMR0575

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Tohma, T; Masumoto, H; Hirai, T; Goto, T

*Preparation of barium titanate film by metal-organic chemical vapor deposition and its thermodynamic analysis*

Mater. Trans.

42 (2001) 702 – 706

01-IMR0576

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Ma, YW; Watanabe, K; Awaji, S; Masumoto, H; Motokawa, M

*Effect of magnetic field on growth of YBa<sub>2</sub>Cu<sub>3</sub>O<sub>7</sub> films on MgO substrates by metalorganic chemical vapor deposition*

Physica C-Superconductivity and Its Application

353 (2001) 283 – 288

01-IMR0082

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Goto, T; Ono, T; Hirai, T

*Electrochemical properties of iridium-carbon nano composite films prepared by MOCVD*

Scr. Mater.

44 (2001) 1187 – 1190

01-IMR0576

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Thermoelectric properties of n-type BayNixCo<sub>4-x</sub>Sb<sub>12</sub>*

Acta Phys. Sin.

51 (2002) 2823 – 2828

02-IMR0589

Goto, T; Homma, H; Hirai, T

*Effect of oxygen partial pressure on the high-temperature oxidation of CVD SiC*

Corrosion Sci.

44 (2002) 359 – 370

02-IMR0590

Goto, T

*High-temperature oxidation behavior of chemical vapor deposited silicon carbide*

J. Ceram. Soc. Jpn.

110 (2002) 884 – 889

02-IMR0591

Goto, T; Homma, H

*High-temperature active/pассив oxidation and bubble formation of CVD SiC in O<sub>2</sub> and CO<sub>2</sub> atmospheres*

J. European Ceram. Soc.

22 (2002) 2749 – 2756

02-IMR0592

Tang, XF; Chen, LD; Goto, T; Hirai, T; Yuan, RZ

*Synthesis and thermoelectric properties of p-type barium-filled skutterudite BayFe<sub>x</sub>Co<sub>4-x</sub>Sb<sub>12</sub>*

J. Mater. Res.

17 (2002) 2953 – 2959

02-IMR0593

Tang, XF; Chen, LD; Zhang, LM; Goto, T; Hirai, T; Yuan, RZ

*Effect of Ba filling fraction on thermoelectric properties of p-type BayFe<sub>1.6</sub>CO<sub>2.4</sub>Sb<sub>12</sub>*

J. Wuhan Univ. Technol.-Mat. Sci.

17 (2002) 8 – 12

Edit.

02-IMR0594

Tohma, T; Masumoto, H; Goto, T

*Preparation of BaTiO<sub>3</sub>-BaZrO<sub>3</sub> films by metal-organic chemical vapor deposition*

Jpn. J. Appl. Phys. Part 1 – Regul.

41 (2002) 6643 – 6646

Pap. Short Notes Rev. Pap.

02-IMR0595

Masumoto, H; Kojima, A; Iijima, T; Goto, T

*Preparation of Ag-alloy top-electrode for ferroelectric Pb(Zr,Ti)O<sub>3</sub> films under various atmospheres*

Jpn. J. Appl. Phys. Part 1 – Regul.

41 (2002) 6882 – 6885

Pap. Short Notes Rev. Pap.

02-IMR0596

Goto, T; Masumoto, H; Niizuma, M

*Low temperature oxidation of CVD SiC by electron cyclotron resonance plasma*

Mater. Chem. Phys.

75 (2002) 235 – 240

02-IMR0597

Akashi, T; Itoh, T; Gunjishima, I; Masumoto, H; Goto, T

*Thermoelectric properties of hot-pressed boron suboxide (B<sub>6</sub>O)*

Mater. Trans.

43 (2002) 1719 – 1723

02-IMR0599

Gunjishima, I; Akashi, T; Goto, T

*Characterization of directionally solidified B4C-SiC composites prepared by a Floating Zone method*  
Mater. Trans. 43 (2002) 2309 – 2315

02-IMR0600

Tu, R; Kimura, T; Goto, T

*Rapid synthesis of yttria-partially-stabilized zirconia films by metal-organic chemical vapor deposition*  
Mater. Trans. 43 (2002) 2354 – 2356

02-IMR0601

Zhang, BP; Masumoto, H; Someno, Y; Goto, T

*Preparation of Au/SiO<sub>2</sub> nano-composite multilayers by helicon plasma sputtering and their optical properties*  
Mater. Trans. 43 (2002) 2855 – 2859

02-IMR0602

Tohma, T; Masumoto, H; Goto, T

*Microstructure and dielectric properties of barium titanate film prepared by MOCVD*  
Mater. Trans. 43 (2002) 2880 – 2884

02-IMR0603

Gunjishima, I; Akashi, T; Goto, T

*Characterization of directionally solidified B4C-TiB<sub>2</sub> composites prepared by a floating zone method*  
Mater. Trans. 43 (2002) 712 – 720

02-IMR0598

Fujishiro, H; Ikebe, M; Akashi, T; Goto, T

*Thermal diffusivity of La<sub>1-X</sub>Ca<sub>X</sub>MnO<sub>3</sub> up to 1200K*  
Physica B 316 (2002) 261 – 264

02-IMR0604

Kimura, T; Goto, T; Yamane, H; Iwata, H; Kajiwara, T; Akashi, T  
*A ferroelectric barium titanate,*  
Acta Crystallogr. Sect. C-Cryst. Struct. Commun. 59 (2003) I128 – I130

03-IMR0525

Tu, R; Goto, T  
*Oxidation of Hastelloy-XR alloy for corrosion-resistant*  
J. Mater. Sci. Technol. 19 (2003) 19 – 22

03-IMR0527

Shen, Q; Zhang, LM; Chen, LD; Goto, T; Hirai, T  
*Synthesis and sintering of ZrNiSn-based half-Heusler*  
J. Mater. Sci. Technol. 19 (2003) 511 – 512

03-IMR0528

Tohma, T; Masumoto, H; Goto, T  
*Dielectric properties of Ba(Ti0.85Zr0.15)O-3 film prepared by metalorganic chemical vapor*  
Jpn. J. Appl. Phys. Part 1 – Regul. 42 (2003) 6969 – 6972  
Pap. Short Notes Rev. Pap.

03-IMR0529

Miyazaki, H; Kimura, T; Goto, T  
*Acceleration of deposition rates in a chemical vapor deposition process by laser*  
Jpn. J. Appl. Phys. Part 2 – Lett. 42 (2003) L316 – L318

03-IMR0530

Akashi, T; Gunjishima, I; Goto, T  
*Characterization of directionally solidified B4C-TiB2 and B4C-SiC eutectic composites prepared by floating-zone method*  
Key Eng. Mat. 247 (2003) 209 – 212

03-IMR0531

Ito, A; Masumoto, H; Goto, T  
*Optical properties of Au nanoparticle dispersed TiO2 films prepared by laser*  
Mater. Trans. 44 (2003) 1599 – 1603

03-IMR0537

Akashi, T; Iwata, H; Goto, T  
*Dielectric property of single crystalline BaTi2O5 prepared by a floating zone*  
Mater. Trans. 44 (2003) 1644 – 1646

03-IMR0538

Garcia, JRV; Goto, T  
*Chemical vapor deposition of iridium, platinum, rhodium and*  
Mater. Trans. 44 (2003) 1717 – 1728

03-IMR0539

Kim, TS; Kang, IC; Goto, T; Lee, BT  
*Fabrication of continuously porous alumina body by fibrous monolithic and sintering*  
Mater. Trans. 44 (2003) 1851 – 1856

03-IMR0540

Zhang, BP; Masumoto, H; Someno, Y; Goto, T

*Optical properties of Au/SiO<sub>2</sub> nano-composite films prepared by induction-coil-coupled plasma sputtering*

Mater. Trans. 44 (2003) 215 – 219

03-IMR0532

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Narushima, T; Goto, T; Maruyama, M; Arashi, H; Iguchi, Y

*Oxidation of boron carbide–silicon carbide composite at 1073 to 1773*

Mater. Trans. 44 (2003) 401 – 406

03-IMR0533

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Kimura, T; Goto, T

*Rapid synthesis of yttria-stabilized zirconia films by laser chemical vapor*

Mater. Trans. 44 (2003) 421 – 424

03-IMR0534

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Akashi, T; Iwata, H; Goto, T

*Preparation of BaTi<sub>2</sub>O<sub>5</sub> single crystal by a floating zone*

Mater. Trans. 44 (2003) 802 – 804

03-IMR0535

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Tu, R; Goto, T

*Corrosion behavior of ceramics-coated Hastelloy-XR alloy in an Ar-SO<sub>2</sub>*

Mater. Trans. 44 (2003) 962 – 967

03-IMR0536

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Yonenaga, I; Itoh, S; Goto, T

*Dislocation mobility and photoluminescence of plastically deformed*

Physica B 340 (2003) 484 – 487

03-IMR0221

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Goto, T; He, G; Narushima, T; Iguchi, Y

*Application of Sr beta-alumina solid electrolyte to a CO<sub>2</sub> gas*

Solid State Ion. 156 (2003) 329 – 336

03-IMR0541

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Zhang, AY; Akashi, T; Goto, T

*Anisotropy of electrical conductivity for alkaline earth beta-alumina single crystals prepared by a floating zone method*

Solid State Ion. 156 (2003) 349 – 355

03-IMR0542

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Zhang, AY; Akashi, T; Goto, T

*Electrical conductivity of non-stoichiometric Sr beta-alumina single crystals prepared by a floating zone method*

Solid State Ion. 156 (2003) 425 – 431

03-IMR0543

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Akashi, T; Maruyama, T; Goto, T

*Transport of lanthanum ion and hole in LaCrO<sub>3</sub> determined by electrical conductivity*

Solid State Ion. 164 (2003) 177 – 183

03-IMR0544

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Kimura, T; Goto, T

*Preparation of RuO<sub>2</sub>-YSZ nano-composite films by  
Surf. Coat. Technol.* 167 (2003) 240 – 244

03-IMR0545

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Tsujuchi, Y; Suto, J; Goto, K; Shibata, S; Ishimaru, T; Ihara, M; Masumoto, H; Goto, M

*Preparation of hydrogenated amorphous silicon by ECR plasma sputtering and the effect on retinoic acid and membrane protein polypeptides  
Thin Solid Films* 438 (2003) 90 – 96

03-IMR0546

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Tang, XF; Chen, LD; Jun, W; Luo, PF; Zhang, QJ; Goto, T; Hirai, T; Yuan, RZ

*Lattice thermal conductivity of RyMx Co<sub>4-x</sub>Sb<sub>12</sub>*

Acta Phys. Sin. 53 (2004) 1463 – 1468

04-IMR0532

Waghmare, U; Sluiter, MHF; Kimura, T; Goto, T; Kawazoe, Y

*A lead-free high-T-C ferroelectric BaTi<sub>2</sub>O<sub>5</sub>: A first-principles study*

Appl. Phys. Lett. 84 (2004) 4917 – 4919

04-IMR0172

Miyazaki, H; Goto, T; Miwa, Y; Ohno, T; Suzuki, H; Ota, T; Takahashi, M

*Preparation and evaluation of LaNiO<sub>3</sub> thin film electrode with chemical solution deposition*

J. European Ceram. Soc. 24 (2004) 1005 – 1008

04-IMR0533

Masumoto, H; Goto, T

*Ionic conductivity enhancement of YSZ film induced by piezoelectric vibration*

Mater. Trans. 45 (2004) 240 – 243

04-IMR0534

Liu, YX; Masumoto, H; Goto, T

*Electrical and optical properties of IrO<sub>2</sub> thin films prepared by laser-ablation*

Mater. Trans. 45 (2004) 3023 – 3027

04-IMR0537

Kim, TS; Kim, KH; Goto, T; Lee, BT

*Microstructure control of Al<sub>2</sub>O<sub>3</sub>/ZrO<sub>2</sub> composite by fibrous monolithic process*

Mater. Trans. 45 (2004) 431 – 434

04-IMR0535

Liu, YX; Masumoto, H; Goto, T

*Preparation of IrO<sub>2</sub> thin films by oxidating laser-ablated Ir*

Mater. Trans. 45 (2004) 900 – 903

04-IMR0536

Kim, TS; Jang, DH; Goto, T; Lee, BT

*Microstructure control of Al<sub>2</sub>O<sub>3</sub>-ZrO<sub>2</sub> composite by fibrous monolithic process*

Rev. Adv. Mater. Sci. 6 (2004) 1 – 6

04-IMR0538

Zhang, AY; Akashi, T; Goto, T

*Electrical conductivity of nonstoichiometric Ba beta-alumina single crystals prepared by a floating zone method*

Solid State Ion. 166 (2004) 77 – 82

04-IMR0539

Goto, T

*High-speed deposition of zirconia films by laser-induced plasma CVD*

Solid State Ion. 172 (2004) 225 – 229

04-IMR0540

Tu, R; Kimura, T; Goto, T

*High-speed deposition of yttria stabilized zirconia by MOCVD*

Surf. Coat. Technol.

187 (2004) 238 – 244

04-IMR0541

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